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10/550,897	09/27/2005 RULE	438	2822	Q90606
APPLICANTS Akira Kobayashi, Yokohama, JAPAN; Tsunehisa Namiki, Yokohama, JAPAN; Hiroko Hosono, Yokohama, JAPAN; Hideo Kurashima, Yokohama, JAPAN; Hajime Inagaki, Yokohama, JAPAN; Toshihide Ieki, Yokohama, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/03992 03/23/2004				
** FOREIGN APPLICATIONS ***** JAPAN 2003-092265 03/28/2003 JAPAN 2003-206714 08/08/2003				
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/14/2006				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /KEVIN M. PICARDAT/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 8	TOTAL CLAIMS 14
INDEPENDENT CLAIMS 2				
ADDRESS SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES				
TITLE Chemical vapor deposited film based on a plasma cvd method and method of forming the film				
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	